

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	66	semiconductor and (donor adj wafer) and (handle adj wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 13:01

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	895	semiconductor and donor and transfer and cleav\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 15:39
L2	190	1 and hydrogen and helium	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 15:40

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	20019	oxide and voids and apparatus	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 18:41
L2	3497	1 and anneal\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 18:41
L3	2346	2 and ions	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 18:42
L4	165	3 and donor and (handle or target)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/08 18:42